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Attorney's Docket No. 004192.P053D

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:

Min-hwa Chi

Application No. 09/865,929

Filed: May 24, 2001

For: TRANSISTOR AND LOGIC CIRCUIT
ON THIN SILICON-ON-INSULATOR
WAFERS BASED ON GATE INDUCED
LEAKAGE CURRENTS

Examiner: Kang, Donghee

Art Unit: 2811

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Assistant Commissioner for Patents
Attn: Chief Draftsperson
Washington, D.C. 20231

REQUEST FOR APPROVAL OF DRAWING CHANGE UNDER 37 C.F.R. § 1.121

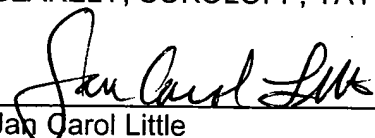
Sir:

Applicants respectfully request approval of new drawing for Fig. 10A for the
above-identified application as enclosed.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Dated: 4/10/02


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